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PATENT APPLICATION

Attorney Docket No.: 107312

AMENDMENT TRANSMITTAL

In re the Application of

Saburo KAMIYA

Group Art Unit: 2877

Application No.: 09 661,433

Examiner: S. Turner

Filed: September 13, 2000

For: EXPOSURE APPARATUS AND DEVICE PRODUCTION METHOD IN WHICH POSITION OF
REFERENCE PLATE PROVIDED ON SUBSTRATE STAGE IS MEASURED (AS AMENDED)

Director of the U.S. Patent and Trademark Office
Washington, D.C. 20231

Sir:

Transmitted herewith is an Amendment in the above-identified application.

- ☐ Entitlement to small entity status is hereby asserted.
☐ Small entity status of this application has been established.

The filing fee has been calculated as shown below:

(Column 1)		(Column 2)	(Column 3)	SMALL ENTITY		OR	OTHER THAN A SMALL ENTITY	
	CLAIMS REMAINING AFTER AMENDMENT	HIGHEST NO. PREVIOUSLY PAID FOR	PRESENT EXTRA	RATE	ADD'L FEE		RATE	ADD'L FEE
TOTAL CLAIMS	*26 MINUS	**20	=6	x 9	\$		x 18	\$ 108
INDEP CLAIMS	*4 MINUS	***3	=1	x 42	\$		x 84	\$ 84
<input type="checkbox"/> FIRST PRESENTATION OF MULTIPLE DEP. CLAIM				+ 140	\$	OR	+ 280	\$
					\$			\$ 192

* If the entry in Column 1 is less than the entry in Column 2, write "0" in Column 3.

** If the "Highest Number Previously Paid For" IN THIS SPACE is less than 20, write "20" in this space.

*** If the "Highest Number Previously Paid For" IN THIS SPACE is less than 3, write "3" in this space.

The "Highest Number Previously Paid For" in this space (Total or Independent) is the highest number found from the equivalent box in Column 1 of a prior Amendment or the number of claims originally filed.

- ☒ Check No. 133859 in the amount of \$192.00 is attached. The Director is hereby authorized to charge any other fees that may be required to complete this filing, or to credit any overpayment, to Deposit Account No. 15-0461. Two duplicate copies of this sheet are attached.

DEPOSIT ACCOUNT USE
AUTHORIZATION
Please grant any extension
necessary for entry;
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Deposit Account No. 15-0461

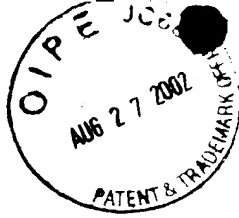
Respectfully submitted,

Mario A. Costantino
Registration No. 33,565

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Date: August 27, 2002



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Saburo KAMIYA

Group Art Unit: 2877

Application No.: 09/661,433

Examiner: S. Turner

Filed: September 13, 2000

Docket No.: 107312

For: EXPOSURE APPARATUS AND DEVICE PRODUCTION METHOD IN WHICH
POSITION OF REFERENCE PLATE PROVIDED ON SUBSTRATE STAGE IS
MEASURED (As Amended)

AMENDMENT

Director of the U.S. Patent and Trademark Office
Washington, D.C. 20231

Sir:

In reply to the March 27, 2002 Office Action, the shortened statutory period for reply
being extended by the attached Petition for Extension of Time, please amend the above-
identified application as follows:

IN THE TITLE:

Please replace the title with the following amended title:

EXPOSURE APPARATUS AND DEVICE PRODUCTION METHOD IN WHICH
POSITION OF REFERENCE PLATE PROVIDED ON SUBSTRATE STAGE IS
MEASURED

IN THE CLAIMS:

Please cancel claims 7 and 8 without prejudice to or disclaimer of the subject matter
contained therein.

Please replace claims 1-6 and 9-15 as follows:

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